

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L18	8	((substrate or wafer or semiconductor) and rotat\$3 and gas and (control\$4 or adjust\$3) and (flow rate) and first and second and mov\$3 and (region or area or place or location)).clm.	US-PGPUB	ADJ	ON	2005/10/16 12:18